

Docket No.: 5016-0102PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Tadahiro OHMI et al.

Application No.: 10/558,934

Confirmation No.: 6405

Filed: December 2, 2005

Art Unit: 2871

For: SUBSTRATE AND METHOD OF
MANUFACTURING THE SAME

Examiner: D. D. Luong

REPLY TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Restriction Requirement dated July 29, 2008, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Remarks